



Attorney's Docket No.: 10417-101001 / F51-136645M/TOM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Haruo Hyodo et al.

Art Unit : 2822

Serial No. : 09/963,267

Examiner : Ida M. Soward

Filed : September 26, 2001

Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Commissioner for Patents  
Washington, D.C. 20231

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COMMUNICATION TO FULFILL THE DUTY TO INFORM


THE EXAMINER ON MATERIAL CO-PENDING US APPLICATIONS

In response to a duty to disclose information material to patentability under CFR §1.56,  
Applicants comment as follows:

In request to fulfill the duty to inform the Examiner on any co-pending US applications  
material to the present application, Applicants bring to the attention of the Examiner, Application  
Serial No. 09/963,839 (Attorney Docket No.: 10417-100001).

Respectfully submitted,

Date: 12/06/02

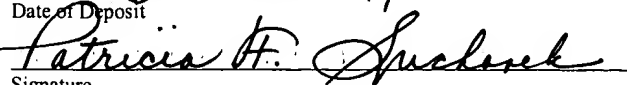
  
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